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NAME OF INVENTOR(S): Jaiswal	
RECEIPT DATE & SERIAL NO.: Serial No.: 10/679,783	
Filing Date: 10/6/2003	
TITLE OF INVENTION: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH	
TI FILE NO.: TI-34403.1	DEPOSIT ACCT. NO.: 20-0668
FAXED: 3-18-05 DUE: 03/28/2005 ATTY/SEC'Y: WDS/uc	

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Texas Instruments Incorporated
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MAR 18 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jaiswal
Serial No: 10/679,783
Filed: 10/6/2003
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT
USING RF PLASMA SPUTTER ETCH

Docket No: TI-34403.1
Examiner: McDonald, Rodney Glenn
Art Unit: 1753

AMENDMENT UNDER 37 C.F.R. § 1.116

Assistant Commissioner For Patents
Washington, DC 20231

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Tommy Chambers
Tommy Chambers

Dear Sir:

Responsive to the Office Action mailed January 28, 2005 in connection with the
above identified application, Applicants respectfully submit the following amendments
and remarks.

TI-34403.1 - 1 -